

## Macroporous silicon membrane (450199-W14)

### Etching

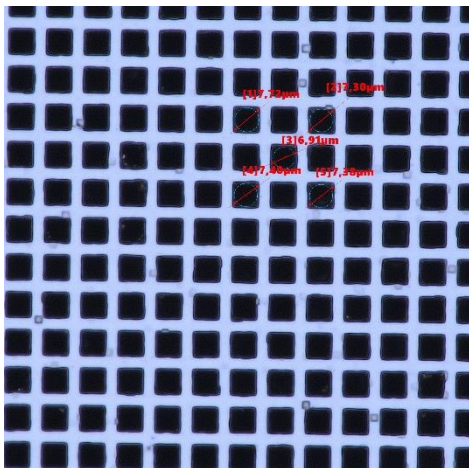
<b>Wafer Size:</b>	6 inch
<b>Pitch:</b>	12 $\mu\text{m}$ square
<b>Pore length:</b>	322 $\mu\text{m}$ membrane thickness
<b>Pore Diameter:</b>	6 $\mu\text{m}$

### Postprocessing

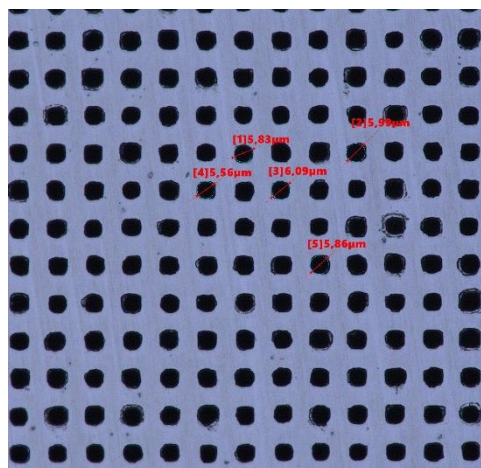
- Backside grinding & polishing
- Laserdicing

### Images

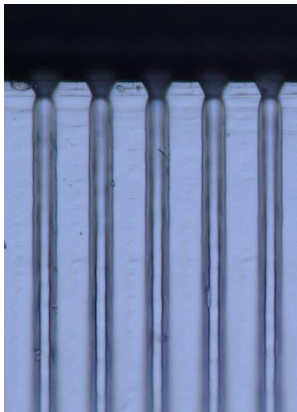
Top view



Bottom view



Side view (generic) (SEM)



### Remarks

Please note: According to our factsheets a bottleneck as pictured on the left may exist close below the surface.